

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

71B
12-11-00
C. Brown

Applicant : Hidemi Takasu
Serial No. : 09/212,915 Examiner: M. Estrada
Filed : December 16, 1998 Group Art Unit: 2823
For : PROCESS FOR FABRICATING A
SEMICONDUCTOR DRIVE



AMENDMENT

I hereby certify that this paper is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Assistant Commissioner for Patents, Washington, D.C. 20231, on:

November 29, 2000

Date of Deposit

Francis J. Hone

Attorney Name

[Signature]
Signature

18,662

PTO Reg. No.

November 29, 2000

Date of Signature

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

RECEIVED
DEC 08 2000
TECHNOLOGY CENTER 2800

In response to the Examiner's Action mailed August 30, 2000, please amend the
above-identified application as follows:

In the Specification:

Page 1, line ²/₃, change "of" to --on--.

(c)

ME
02/12/01